

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

Application No.:	10/519,700	)
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Filing Date:	September 14, 2005	)
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Inventor(s):	Krull	)
		)
Group Art Unit:	1765	)
		)
		)
Examiner Name:	Angadi,Maki A	)
		)
Customer No.:	27160	)
		)
Confirmation No.:	6925	)
		)
Title:	ION IMPLANTATION ION	)
	SOURCE, SYSTEM AND METHOD	)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Official Action, mailed on August 6, 2007, please enter the following preliminary amendment.

**Amendments to the Specification** are reflected on page 2 of this paper.

**Remarks** begin on page 8 of this paper.